

PATENT 1FW

Case Docket No. RYUKA.007AUS

Date: July 7, 2004

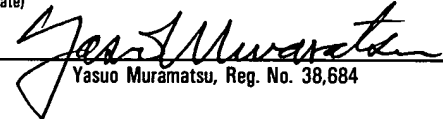
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shin-ichi Hashimoto et al.
App. No. : 10/672,469
Filed : September 26, 2003
For : ELECTRON BEAM EXPOSURE APPARATUS,
DEFLECTION APPARATUS, AND ELECTRON
BEAM EXPOSURE METHOD
Examiner : Anthony G. Quash
Art Unit : 2881

I hereby certify that this correspondence and all marked attachments
are being deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on

July 7, 2004

(Date)


Yasuo Muramatsu, Reg. No. 38,684

TRANSMITTAL LETTER

ASSISTANT COMMISSIONER FOR PATENTS
ALEXANDRIA, VA 22313-1450

Dear Sir:

Transmitted herewith is a response to the office action in the above-identified utility application.

() An extension of time to respond for two month(s) is hereby requested.

Time Extension Fee:

- ☐ one month(\$110 large entity)
- ☐ two months(\$420 large entity)
- ☐ three months (\$950 large entity)

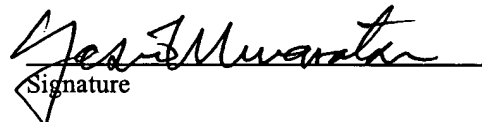
Enclosed are:

(X) Amendment in fourteen (14) pages.

(X) Return prepaid postcard.

SEND ALL CORRESPONDENCE TO:

MURAMATSU & ASSOCIATES
7700 Irvine Center Drive
Suite 225
Irvine, CA 92618
Tel: 949-753-1127


Signature

Yasuo Muramatsu
Printed Name

38,684
Registration Number



RYUKA.007A06

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shin-Ichi Hashimoto et al.) Art Unit 2881
Appl. No. : 10/672,469)
Filed : September 26, 2003)
For : ELECTRON BEAM EXPOSURE)
APPARATUS, DEFLECTION)
APPARATUS, AND ELECTRON)
BEAM EXPOSURE METHOD)
Examiner : Anthony G. Quash)

AMENDMENT

Hon. Commissioner
of Patents and Trademarks
Washington, D.C. 20231

Dear Sir:

This amendment is submitted in response to the office action mailed April 8, 2004 from the United States Patent and Trademark Office for the above-identified patent application. Please make the following changes: